

a third mirror surface located at an opposite end of the annular optical cavity; and
an output coupler operative to receive, reflect and transmit a beam reflected by said second
mirror surface.

2. A laser according to claim 1 and wherein said first mirror surface is an off-axis parabolic rotationally symmetric surface.

3. (Amended) A laser according to claim 1 and wherein said second mirror surface is an off-axis ellipsoidal rotationally symmetric surface.

4. (Amended) A gas laser according to claim 1 and wherein:
said annular optical cavity is defined by inner and outer coaxial spaced electrodes which produces an annular coherent beam; and
said gas laser also comprises an RF power supply coupled to said outer electrode at at least one location symmetrical with respect to the length thereof.

5. A gas laser according to claim 4 and wherein the inner electrode is grounded.

6. (Amended) A gas laser according to claim 4 and comprising a grounded structure surrounding the annular optical cavity.

7. A gas laser according to claim 6 and wherein first and second ends of said outer electrode are coupled to said grounded structure via a plurality of induction coils.

8. A gas laser according to claim 4 and wherein said at least one location is a location centered with respect to the length of said outer electrode.

9. (Amended) A gas laser according to claim 1 and wherein said mirror structure is grounded.

10. A gas laser comprising:
an annular optical cavity defined by inner and outer coaxial spaced electrodes which produces an annular coherent beam; and
an RF power supply coupled to said outer electrode at at least one location symmetrical with respect to the length thereof.

11. A gas laser according to claim 10 and wherein the inner electrode is grounded.

A4	1	12. (Amended) A gas laser according to claim 10 and comprising a grounded
	2	structure surrounding the annular optical cavity.
A5	1	13. A gas laser according to claim 12 and wherein first and second ends of
	2	said outer electrode are coupled to said grounded structure via a plurality of induction coils.
	1	14. A gas laser according to claim 10 and wherein said at least one location is
	2	a location centered with respect to the length of said outer electrode.
	1	15. (Amended) A gas laser according to claim 10 and also comprising:
	2	a grounded structure surrounding the annular optical cavity and including first and
A6	3	second portions having precisely formed first and second mating surfaces,
	4	said first portion having machined thereon a first mirror structure located at one
	5	end of the annular optical cavity; and
	6	said second portion having machined thereon a second mirror structure located at one end of the
	7	annular optical cavity.
	1	16. A gas laser according to claim 15 and wherein said first mating surface
A6	2	and said first mirror structure are machined together so as to ensure desired alignment
	3	therebetween.
	1	17. (Amended) A gas laser according to claim 15 and wherein said second
	2	mating surface and said second mirror structure are machined together so as to ensure desired
	3	alignment therebetween.
	1	18. (Amended) A gas laser according to claim 15 and wherein said first
A6	2	mirror structure comprises:
	3	a first mirror surface which is operative to decrease the diameter of the annular
	4	coherent beam from said first diameter and to expand the thickness of the annular coherent beam
	5	from said first thickness;
	6	a second mirror surface which is operative to focus an annular beam reflected by
	7	said first mirror surface to a location located interior of said pair of coaxial spaced electrodes;
A6	8	and
	9	a spatial filter disposed at said location located interior of said pair of coaxial spaced electrodes.
A6	1	19. A gas laser according to claim 18 and wherein said second mirror structure
	2	comprises:

a third mirror surface located at an opposite end of the annular optical cavity.

20. (Amended) A gas laser according to claim 15 and also comprising an output coupler.

21. A gas laser comprising:
an annular optical cavity defined by inner and outer coaxial spaced electrodes which produces an annular coherent beam;
a grounded structure surrounding the annular optical cavity and including first and second portions having precisely formed first and second mating surfaces,
said first portion having machined thereon a first mirror structure located at one end of the annular optical cavity; and
said second portion having machined thereon a second mirror structure located at one end of the annular optical cavity.

22. A gas laser according to claim 21 and wherein said first mating surface and said first mirror structure are machined together so as to ensure desired alignment therebetween.

23. (Amended) A gas laser according to claim 21 and wherein said second mating surface and said second mirror structure are machined together so as to ensure desired alignment therebetween.

24. (Amended) A gas laser according to claim 21 and wherein said first mirror structure comprises:
a first mirror surface which is operative to decrease the diameter of the annular coherent beam from said first diameter and to expand the thickness of the annular coherent beam from said first thickness;
a second mirror surface which is operative to focus an annular beam reflected by said first mirror surface to a location located interior of said pair of coaxial spaced electrodes;
and
a spatial filter disposed at said location located interior of said pair of coaxial spaced electrodes.

25. A gas laser according to claim 24 and wherein said second mirror structure comprises:
a third mirror surface located at an opposite end of the annular optical cavity.

A9	1 2	26. (Amended) A gas laser according to claim 19 and also comprising an output coupler.
	1 2 3 4 5 6 7	27. A gas laser comprising: an enclosure; an annular optical cavity defined by inner and outer coaxial spaced electrodes disposed within said enclosure and which produces art annular coherent beam; and a plurality of RF power supplies mounted onto said enclosure and coupled to said outer electrode at multiple locations thereon distributed along the length and circumference thereof, thereby to provide generally homogeneous power and voltage distribution throughout said cavity.
	1 2	28. A gas laser according to claim 27 and wherein the inner electrode is grounded.
A10	1 2	29. (Amended) A gas laser according to claim 27 and comprising a grounded structure surrounding the annular optical cavity.
	1 2	30. A gas laser according to claim 29 and wherein first and second ends of said outer electrode are coupled to said grounded structure via a plurality of induction coils.
A11	1 2 3	31. (Amended) A gas laser according, to claim 27 and wherein said second mating surface and said second mirror structure are machined together so as to ensure desired alignment therebetween.
	1 2 3	32. A gas laser according to claim 31 and wherein said first mating surface and said first mirror structure are machined together so as to ensure desired alignment therebetween.
A12	1 2 3	33. (Amended) A gas laser according to claim 30 and wherein said second mating surface and said second mirror structure are machined together so as to ensure desired alignment therebetween.
	1 2 3 4 5	34. (Amended) A gas laser according to claim 30 and wherein said first mirror structure comprises: a first mirror surface which is operative to decrease the diameter of the annular coherent beam from said first diameter and to expand the thickness of the annular coherent beam from said first thickness;